



Date: June 18, 2001

Group Art: 1741

P/2292-29

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Seok-Keun KOH et al.

Serial No.: 09/509,725

Filed: March 29, 2000

For:

Examiner: Mayekar, K.

PLASMA POLYMERIZATION ON SURFACE OF MATERIAL

Hon. Commissioner for Patents Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

REMARKS

Responsive to the Election/Restriction Requirement dated May 16, 2001, the applicants elec prosecute in the present application the claims directed to Group I, namely claims 1-13, 20, 25 and 30. Of course, the interposition of the Restriction Requirement means that the non-elected claims a patentably distinct from the elected claims.

Applicants reserve the right to file a divisional application directed towards the non-elected claims.

Early and favorable consideration of the present application is earnestly solicited.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on June 18, 2001:

Max Moskowitz

Name of Person Mailing Correspondence

Signature June 18, 200

Date of Signature

MM:mcm

Respectfully submitted,

Max Moskowitz

Registration No.: 30,576

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

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